

MiCS-4514 with recommended supply circuit (top view)

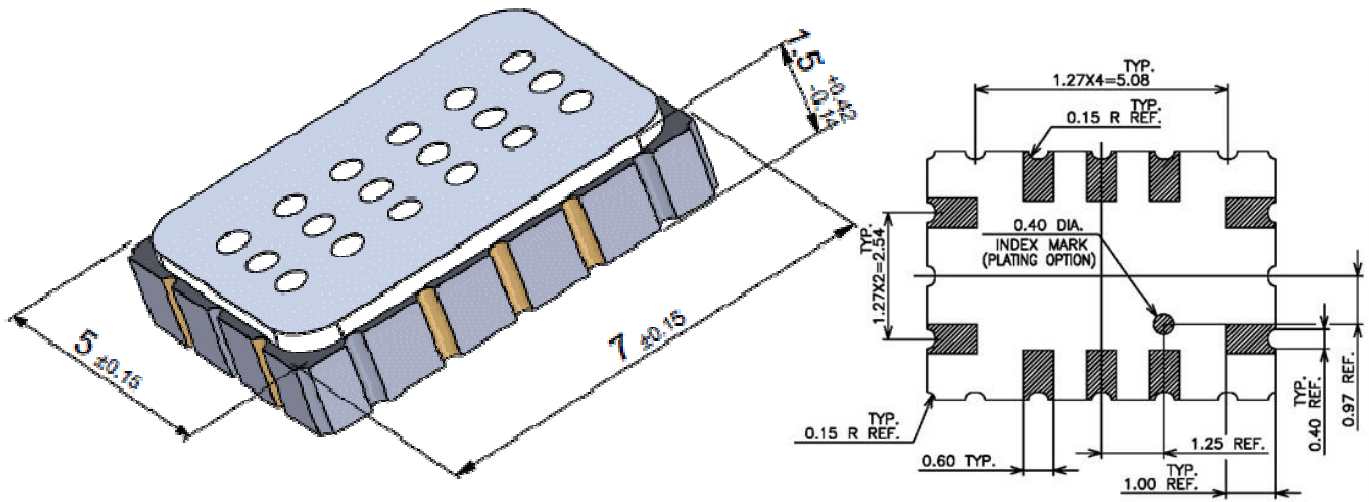
RDRED is a 82  $\Omega$  and RDOX is a 133 $\Omega$ . These resistors are necessary to obtain the right temperatures on the two independant heaters while using a single 5V power supply. The resulting voltages are typically  $V_{HRED} = 2.4V$  and  $V_{HOX} = 1.7V$ .

MiCS-4514 with measurement circuit (top view)

The two voltages measured on the load resistors are directly linked to the resistances of the RED and OX sensors respectively. RLOAD must be 820  $\Omega$  at the lowest in order not to damage the sensitive layer.

Parameter RED sensor/OX sensor	Symbol	Typ	Min	Max	Unit
Heating power	$P_H$	76/43	71/30	88/50	mW
Heating voltage	$V_H$	2.4/1.7	-	-	V
Heating current	$I_H$	32/26	-	-	mA
Heating resistance at nominal power	$R_H$	74/66	66/59	82/73	$\Omega$

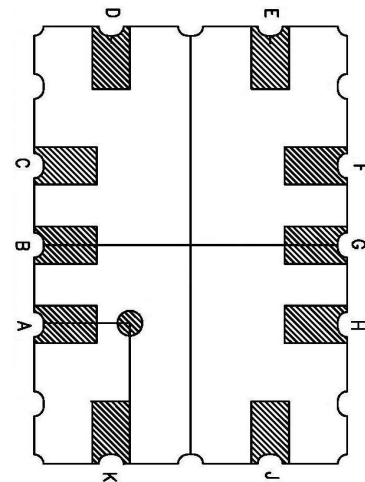
Rating	Symbol	Value / Range	Unit
Maximum heater power dissipation	$P_H$	88 (RED sensor)/ 50 (OX sensor)	mW
Maximum sensitive layer power dissipation	$P_s$	8	mW
Voltage supply with adapted resistors	$V_{supply}$	4.9 – 5.1	V
Relative humidity range	RH	5 – 95	%RH
Ambient operating temperature	$T_{amb}$	-30 – 85	$^{\circ}C$
Storage temperature range	$T_{sto}$	-40 – 120	$^{\circ}C$
Storage humidity range	RHsto	5 - 95	%RH



## Package outline dimensions

The package is compatible with SMD assembly process.

Pin	Connection
A	Rh1 OX
B	Rs1 OX
C	Rh1 RED
D	Rs1 RED
E	NC
F	Rh2 RED
G	Rs2 RED
H	Rh2 OX
J	Rs2 OX
K	NC



MiCS-4514 configuration (bottom view)

## Sensor configuration

The silicon gas sensor structure consists of an accurately micro machined diaphragm with an embedded heating resistor and the sensing layer on top.

The MiCS-4514 includes two sensor chips with independent heaters and sensitive layers. One sensor chip detects oxidising gases (OX) and the other sensor detects reducing gases (RED). The internal connections are shown above.